Electronic Pat	ent Ap <sub>l</sub>	olication Fee	e Transmit	tal			
Application Number:	10	10583348					
Filing Date:	05	05-Apr-2007					
Title of Invention:	Su	Method for Removing Deposit from Substrate and Method for Drying Substrate, as Well as Apparatus for Removing Deposit from Substrate and Apparatus for Drying Substrate Using These Methods					
First Named Inventor/Applicant Name:	Yo	Yoshitaka Nishio					
Filer:	Al	Alan Edwin Schiavelli/kiara ransom					
Attorney Docket Number:	13	1343.46195X00					
Filed as Large Entity							
U.S. National Stage under 35 USC 371 F	iling Fee	es					
Description		Fee Code	Quantity	Amount	Sub-Total in USD(\$)		
Basic Filing:		<u> </u>	II				
Pages:							
Claims:							
Miscellaneous-Filing:							
Petition:							
Patent-Appeals-and-Interference:							
Post-Allowance-and-Post-Issuance:							
Extension-of-Time:							

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Submission- Information Disclosure Stmt	1806	1	180	180
	Tot	180		